

Abstract of the Disclosure

METHOD FOR MANUFACTURING A STRUCTURE WITH CURVED SURFACES

A structure used as an electronic device including a magnetic head, an optical device, or precision parts has a structure body. A thin film is formed on one surface of the structure body by sputtering. The structure body is curved by an inner stress in the thin film, thereby the one surface and the other surface opposite to the one surface being formed into curved surfaces.

Figure 3C.